DO NOT ENTER: /J.K./

September 20, 2010

AMENDMENT UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE GROUP 2815 PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q88048

Masaru KURAMOTO, et al.

Appln. No.: 10/537,611

Group Art Unit: 2815

Confirmation No.: 4984

Examiner: Jay C KIM

Filed: June 3, 2005

For:

NITRIDE SEMICONDUCTOR SUBSTRATE COMPRISING A GROUP III NITRIDE

SEMICONDUCTOR LAYER HAVING REDUCED DISLOCATIONS AND NITRIDE

SEMICONDUCTOR DEVICE EMPLOYING SAME

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AF

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 17, 2010, please amend the above-identified application as follows on the accompanying pages.

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